



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Brask et al.

Examiner: Kin-Chan Chen

Application No.: 10/704,498

Art Unit: 1765

Filed: November 06, 2003

For: A METHOD FOR ETCHING A THIN
METAL LAYER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Examiner:

This is in response to the Final Office Action mailed November 07, 2005 and the Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 filed concurrently herewith. Applicants respectfully request the Examiner to enter this Preliminary Amendment and consider the following remarks.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

on January 9, 2006
Date of Deposit

Teresa Mattox
Name of Person Mailing Correspondence

Teresa Mattox 1/9/06
Signature Date